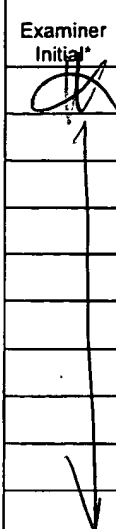



Form PTO-1449 (Rev. 8-88)	U.S. Department of Commerce Patent and Trademark Office	Attorney Docket No. 09792350-0048	Serial No. not yet assigned
<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)		Applicant: Bradley, Kenneth et al.	
		Filing Date December 12, 2003	Group Art Unit: not yet assigned

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							Yes	No
		B1	WO98/53535	11/26/1998			x	
		B2	WO99/39223	08/05/1999			x	
		B3	WO00/29886	05/25/2000			x	
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	C1	Cai, M. et al.; "Highly Efficient Optical Power Transfer to Whispering-Gallery Modes by Use of a Symmetrical Dual-coupling Configuration, No. 25, 15 February 2000, Optics Letters; pages 260-262
	C2	Cai, M. et al.; "Fiber-Optic Add-Drop Device Based on a Silica Microsphere-Whispering Gallery Mode System", No. 6; June 6, 1999; IEEE Photonics Technology Letters; Pages 686-687
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\*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.